

## ICEM13 - PARIS '94

The 13th International Congress on Electron Microscopy will be held in Paris at the *Palais des Congrès (Porte Maillot)* on 17-22 July 1994. As organized under the auspices of the International Federation of Societies for Electron Microscopy (IFSEM), it will be the latest in the series of international meetings, held every four years.

The scientific program will extend over all types of microscopy: transmission and scanning electron, near-field, confocal and ion microscopy as well as microanalytical techniques and related approaches. A considerable part of the meeting will be devoted to applications: materials and their structural, thermodynamic, mechanical, electronic and magnetic properties; biology; medicine; crystallography; mineralogy. Quantitative aspects will be of special importance.

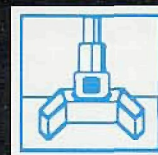
The Congress will be divided into scientific sessions (symposia and posters), workshops, a vast exhibition of scientific material and open laboratories. The scientific exhibition will display a very wide choice of equipment and accessories - and all the latest developments.

After receipt of a "Pre-Registration Form", the organizers will send you a final registration form, hotel registration form, etc. However, they request this first form prior to 1 November 1993. As a friendly service, *Microscopy Today* will fax you a copy of the Pre-Registration Form - you have but to call (608)836-1970 or fax (608)836-1969. Or contact the organizers by writing:

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P.-C. CHENG and T.-H. LIN, Advanced Microscopy and Imaging Lab, SUNY, Buffalo, and  
W.L. WU and J.L. WU, Institute of Zoology, Taipei, Republic of China (eds.)

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